DEC 0 5 2005

Corres. and Mail

MAIL STOP AF
RESPONSE UNDER 37 C.F.R. § 1.116
EXPEDITED PROCEDURE
EXAMINING GROUP 2100

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants:

Y. Granik et al.

Attorney Docket No.: MEGC117332

Application No.: 09/898,431

Group Art Unit: 2123 / Confirmation No. 1914

Filed:

July 2, 2001

Examiner: T.H. Stevens

Title:

METHOD OF COMPENSATING FOR ETCH EFFECTS IN

PHOTOLITHOGRAPHIC PROCESSING

AMENDMENT AFTER FINAL REJECTION UNDER 37 C.F.R. § 1.116/

PETITION FOR EXTENSION OF TIME

Seattle, Washington 98101

December 2, 2005

TO THE COMMISSIONER FOR PATENTS:

INTRODUCTORY COMMENTS

Please amend the above-identified application as follows.

12/06/2005 DTESSEN1 00000062 09898431

01 FC:1251

120.00 OP

LAW OFFICES OF CHRISTENSEN O'CONNOR JOHNSON KINDNESSPACE 1420 Fifth Avenue Suite 2800 Seattle, Washington 98101 206.682.8100